## **RESEARCH ARTICLE**

# Structural Model of a Nano Drive for Biomedical Research

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## ABSTRACT

The structural model of a nano drive is determined for biomedical research. The structural scheme of the piezo drive is obtained. The matrix equation is constructed for a nano drive.

**Keywords:** Nano Drive, Piezo Drive, Structural Model and Scheme, Matrix Equation, Biomedical Research

#### Introduction

A nano drive based on the piezomagnetic, magnetostriction, piezoelectric, electrostriction effects is used for biomedical research, nanomedicine, nanotechnology, nanobiology, microsurgery. The piezo drive is used in scanning microscopy, astronomy for alignment and focusing, image stabilization, in adaptive optics and work with the genes [1-9].

#### **Structural Model**

The expression of electromagnetoelasticity [1-15] has the forn

$$S_i = s^{E,H}_{ij}T_j + d^H_{mi}E_m + d^{E,}_{mi}H_m$$
 - the piezo module,

here  $T_i$  the mechanical stress,  $E_m$  - the electric field strength,

 $H_{m}$ - the magnetic field strength,  $S_{ij}^{E,H}$  - the elastic compliance

for *E*= const, *H* = const,  $d_{mi}^{H}$  - the piezo module,  $d_{mi}^{E}$  - the

magnetostriction coefficient,  $S_i$  - the relative deformation, the axis *i*, *j*, *m*.

Therefore, the expression of the reverse piezo effect [1-15]

$$S_i = d_{mi} E_m + s_{ij}^E T_j$$

and the expression of the magnetostrictive effect [1-15]

$$S_i = d_{mi}H_m + s_{ij}^H T_j$$

The expression of the shift inverse piezo effect [1-15]

$$S_5 = d_{15}E_1 + s_{55}^E T_5$$

The differential equation of a nano drive is calculated [4-58]

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$$\frac{d^2\Xi(x,s)}{dx^2} - \gamma^2\Xi(x,s) = 0$$

here  $\Xi(x,s)$ , x, s,  $\gamma$  are the transform of displacement, the

coordinate, the parameter, the coefficient of propagation.

For the shif piezo drive at 
$$x = 0$$
  $\Xi(0, s) = \Xi_1(s)$  and at

and x = b  $\Xi(b,s) = \Xi_2(s)$  the solution of this differential

equation is calculated

$$\Xi(x,s) = \{\Xi_1(s)\operatorname{sh}[(b-x)\gamma] + \Xi_2(s)\operatorname{sh}(x\gamma)\}/\operatorname{sh}(b\gamma)\}$$

At x=0 and x=b the expressions [11-39] are written

$$T_{5}(0,s) = \frac{1}{s_{55}^{E}} \frac{d\Xi(x,s)}{dx} \bigg|_{x=0} - \frac{d_{15}}{s_{55}^{E}} E_{1}(s)$$
$$T_{5}(b,s) = \frac{1}{s_{55}^{E}} \frac{d\Xi(x,s)}{dx} \bigg|_{x=b} - \frac{d_{15}}{s_{55}^{E}} E_{1}(s)$$

The structural model

$$\Xi_{1}(s) = (M_{1}s^{2})^{-1} \begin{cases} -F_{1}(s) + (\chi_{55}^{E})^{-1} \\ \times \begin{bmatrix} d_{15}E_{1}(s) - [\gamma/\text{sh}(b\gamma)] \\ \times [ch(b\gamma)\Xi_{1}(s) - \Xi_{2}(s)] \end{bmatrix} \end{cases}$$
$$\Xi_{2}(s) = (M_{2}s^{2})^{-1} \begin{cases} -F_{2}(s) + (\chi_{55}^{E})^{-1} \\ \times \begin{bmatrix} d_{15}E_{1}(s) - [\gamma/\text{sh}(b\gamma)] \\ \times [ch(b\gamma)\Xi_{2}(s) - \Xi_{1}(s)] \end{bmatrix} \end{cases}$$

 $\chi^{E}_{55} = s^{E}_{55} / S_0$ 

The expression of the shift magnetostrictive effect [1-15]  $S_5 = d_{15}H_1 + s_{55}^H T_5$ 

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The structural model is transformed

$$\Xi_{1}(s) = (M_{1}s^{2})^{-1} \begin{cases} -F_{1}(s) + (\chi_{55}^{H})^{-1} \\ \times \begin{bmatrix} d_{15}H_{1}(s) - [\gamma/\mathrm{sh}(b\gamma)] \\ \times [\mathrm{ch}(b\gamma)\Xi_{1}(s) - \Xi_{2}(s)] \end{bmatrix} \end{cases}$$
$$\Xi_{2}(s) = (M_{2}s^{2})^{-1} \begin{cases} -F_{2}(s) + (\chi_{55}^{H})^{-1} \\ \times \begin{bmatrix} d_{15}H_{1}(s) - [\gamma/\mathrm{sh}(b\gamma)] \\ \times [\mathrm{ch}(b\gamma)\Xi_{2}(s) - \Xi_{1}(s)] \end{bmatrix} \end{cases}$$

 $\chi^{\rm H}_{\rm 55}=s^{\rm H}_{\rm 55}/S_0$  The expression of the transverse inverse piezo effect [1-15]

 $S_1 = d_{31}E_3 + s_{11}^E T_1$ 

The solution is calculated

$$\Xi(x,s) = \{\Xi_1(s)\operatorname{sh}[(h-x)\gamma] + \Xi_2(s)\operatorname{sh}(x\gamma)\}/\operatorname{sh}(h\gamma)$$

The system at x = 0, and x = h is calculated

$$T_{1}(0,s) = \frac{1}{s_{11}^{E}} \frac{d\Xi(x,s)}{dx} \Big|_{x=0} - \frac{d_{31}}{s_{11}^{E}} E_{3}(s)$$
$$T_{1}(h,s) = \frac{1}{s_{11}^{E}} \frac{d\Xi(x,s)}{dx} \Big|_{x=h} - \frac{d_{31}}{s_{11}^{E}} E_{3}(s)$$

$$\chi_{11}^{E} = s_{11}^{E} / S_{0}$$

The expression of the transverse magnetostrictive effect [1-15]

$$S_1 = d_{31}H_3 + s_{11}^H T_1$$

The structural model is transformed

$$\begin{split} \Xi_{1}(s) &= \left(M_{1}s^{2}\right)^{-1} \begin{cases} -F_{1}(s) + \left(\chi_{11}^{H}\right)^{-1} \\ \times \begin{bmatrix} d_{31}H_{3}(s) - [\gamma/\operatorname{sh}(h\gamma)] \\ \times [\operatorname{ch}(h\gamma)\Xi_{1}(s) - \Xi_{2}(s)] \end{bmatrix} \end{cases} \\ \Xi_{2}(s) &= \left(M_{2}s^{2}\right)^{-1} \begin{cases} -F_{2}(s) + \left(\chi_{11}^{H}\right)^{-1} \\ \times \begin{bmatrix} d_{31}H_{3}(s) - [\gamma/\operatorname{sh}(h\gamma)] \\ \times [\operatorname{ch}(h\gamma)\Xi_{2}(s) - \Xi_{1}(s)] \end{bmatrix} \end{cases} \\ \chi_{11}^{H} &= s_{11}^{H}/S_{0} \end{split}$$

In general at  $I = \{ \delta, h, b \text{ the solution is calculated } \}$ 

$$\Xi(x,s) = \{\Xi_1(s)\operatorname{sh}[(l-x)\gamma] + \Xi_2(s)\operatorname{sh}(x\gamma)\}/\operatorname{sh}(l\gamma)$$

The system is transformed

$$T_{j}(0,s) = \frac{1}{s_{ij}^{\Psi}} \frac{d\Xi(x,s)}{dx} \bigg|_{x=0} - \frac{v_{mi}}{s_{ij}^{\Psi}} \Psi_{m}(s)$$
$$T_{j}(l,s) = \frac{1}{s_{ij}^{\Psi}} \frac{d\Xi(x,s)}{dx} \bigg|_{x=l} - \frac{v_{mi}}{s_{ij}^{\Psi}} \Psi_{m}(s)$$

The structural model on Figure 1 is calculated

$$\Xi_{1}(s) = (M_{1}s^{2})^{-1} \begin{cases} -F_{1}(s) + (\chi_{ij}^{\Psi})^{-1} \\ \times [v_{mi}\Psi_{m}(s) - [\gamma/\operatorname{sh}(l\gamma)]] \\ \times [\operatorname{ch}(l\gamma)\Xi_{1}(s) - \Xi_{2}(s)] \end{cases}$$

$$\Xi_{2}(s) = (M_{2}s^{2})^{-1} \begin{cases} -F_{2}(s) + (\chi_{ij}^{\Psi})^{-1} \\ \times [v_{mi}\Psi_{m}(s) - [\gamma/\operatorname{sh}(l\gamma)]] \\ \times [\operatorname{ch}(l\gamma)\Xi_{2}(s) - \Xi_{1}(s)] \end{cases}$$

$$\chi_{ij}^{\Psi} = s_{ij}^{\Psi} / S_{0}$$

$$v_{mi} = \begin{cases} d_{33}, d_{31}, d_{15} \\ g_{33}, g_{31}, g_{15} \\ d_{33}, d_{31}, d_{15} \end{cases}$$

$$\Psi_{m} = \begin{cases} E_{3}, E_{1} \\ D_{3}, D_{1} \\ H_{3}, H_{1} \end{cases}$$

$$s_{ij}^{\Psi} = \begin{cases} s_{33}^{E}, s_{11}^{E}, s_{55}^{E} \\ s_{33}^{D}, s_{11}^{D}, s_{55}^{D} \\ s_{33}^{D}, s_{11}^{D}, s_{55}^{D} \\ s_{33}^{D}, s_{11}^{D}, s_{55}^{D} \end{cases}$$

$$\gamma = \{\gamma^{E}, \gamma^{D}, \gamma^{H} \\ c^{\Psi} = \{c^{E}, c^{D}, c^{H} \end{cases}$$



Figure 1: Scheme of Nano Drive

The matrix of deformations is calculated

$$\begin{split} & \left( \Xi_{1}(s) \\ \Xi_{2}(s) \right) = \begin{pmatrix} W_{11}(s) & W_{12}(s) & W_{13}(s) \\ W_{21}(s) & W_{22}(s) & W_{23}(s) \end{pmatrix} \begin{pmatrix} \Psi_{m}(s) \\ F_{1}(s) \\ F_{2}(s) \end{pmatrix} \\ & W_{11}(s) = \Xi_{1}(s)/\Psi_{m}(s) = v_{mi} \left[ M_{2}\chi_{ij}^{\Psi}s^{2} + \gamma \text{th}(l\gamma/2) \right] / A_{ij} \\ & A_{ij} = M_{1}M_{2}(\chi_{ij}^{\Psi})^{2}s^{4} + \left[ (M_{1} + M_{2})\chi_{ij}^{\Psi} / \left[ c^{\Psi} \text{th}(l\gamma) \right] \right] s^{3} + \\ & + \left[ (M_{1} + M_{2})\chi_{ij}^{\Psi}\alpha/\text{th}(l\gamma) + 1/(c^{\Psi})^{2} \right] s^{2} + 2\alpha s/c^{\Psi} + \alpha^{2} \\ & W_{21}(s) = \Xi_{2}(s)/\Psi_{m}(s) = v_{mi} \left[ M_{1}\chi_{ij}^{\Psi}s^{2} + \gamma \text{th}(l\gamma/2) \right] / A_{ij} \\ & W_{12}(s) = \Xi_{1}(s)/F_{1}(s) = -\chi_{ij}^{\Psi} \left[ M_{2}\chi_{ij}^{\Psi}s^{2} + \gamma/\text{th}(l\gamma) \right] / A_{ij} \\ & W_{13}(s) = \Xi_{2}(s)/F_{1}(s) = \left[ \chi_{ij}^{\Psi}\gamma/\text{sh}(l\gamma) \right] / A_{ij} \\ & W_{23}(s) = \Xi_{2}(s)/F_{2}(s) = -\chi_{ij}^{\Psi} \left[ M_{1}\chi_{ij}^{\Psi}s^{2} + \gamma/\text{th}(l\gamma) \right] / A_{ij} \end{split}$$

In static the longitudinal deformations

$$\xi_1 = d_{33}UM_2/(M_1 + M_2)$$
  
$$\xi_2 = d_{33}UM_1/(M_1 + M_2)$$

For  $d_{_{33}} = 4 \cdot 10^{-10} \text{ m/V}$ , U= 75 V,  $M_1 = 1 \text{ kg}$ ,  $M_2 = 4 \text{ kg}$  the static deformations  $\xi_1 = 24 \text{ nm}$ ,  $\xi_2 = 6 \text{ nm}$  and  $\xi_1 + \xi_2 = 30 \text{ nm}$  are calculated at error 10%.

The expression of the direct piezo effect has form [1-15]

 $D_m = d_{mi}T_i + \varepsilon_{mk}^E E_k$ 

here  $D_m$ - the electric induction,  $\boldsymbol{\varepsilon}_{mk}^E$  - the permittivity.

The transform for the back electromotive force on Figure 2 is evaluated

$$U_{d}(s) = \frac{d_{mi}S_{0}R}{\delta s_{ii}^{E}} \stackrel{\bullet}{=} n(s) = k_{d}R\stackrel{\bullet}{=} n(s), \ n = 1, 2$$

The reverse and direct coefficients are calculated

$$k_r = k_d = \frac{d_{mi}S_0}{\delta s_{ij}}$$



Figure 2: Scheme of Piezo Drive

At voltage control of the piezo drive its characteristis are evaluated

$$T_{j\max} = E_m d_{mi} / s_{ij}^E$$
$$F_{\max} = E_m d_{mi} S_0 / s_{ij}^E$$

At current control of the piezo drive

$$F_{\max} = \frac{U}{\delta} d_{mi} \frac{S_0}{s_{ij}^E} + \frac{F_{\max}}{S_0} d_{mi} S_c \frac{1}{\varepsilon_{mk}^T S_c / \delta} \frac{1}{\delta} d_{mi} \frac{S_0}{s_{ij}^E}$$

$$\frac{F_{\max}}{S_0} \left( 1 - \frac{d_{mi}^2}{\varepsilon_{mk}^T s_{ij}^E} \right) s_{ij}^E = E_m d_{mi}$$

$$T_{j\max} \left( 1 - k_{mi}^2 \right) s_{ij}^E = E_m d_{mi}$$

$$k_{mi} = d_{mi} / \sqrt{s_{ij}^E \varepsilon_{mk}^T}$$

$$T_{j\max} = E_m d_{mi} / s_{ij}^D$$

$$F_{\max} = E_m d_{mi} S_0 / s_{ij}^D$$

$$s_{ij}^D = \left( 1 - k_{mi}^2 \right) s_{ij}^E$$

here  $S_c$  - the sectional area of the capacitor,  $C_0$  - the capacitance,  $k_{mi}$  - the electromechanical coupling coefficient.

For a nano drive the mechanical and adjustment characteristics [11-26] are evaluated

$$S_{i}(T_{j})\Big|_{\Psi=\text{const}} = \mathbf{v}_{mi}\Psi_{m}\Big|_{\Psi=\text{const}} + s_{ij}^{\Psi}T_{j}$$
$$S_{i}(\Psi_{m})\Big|_{T=\text{const}} = \mathbf{v}_{mi}\Psi_{m} + s_{ij}^{\Psi}T_{j}\Big|_{T=\text{const}}$$

The mechanical characteristic is written

$$\begin{split} \Delta l &= \Delta l_{\max} \left( 1 - F / F_{\max} \right) \\ \Delta l_{\max} &= \mathbf{v}_{mi} \Psi_m l \\ F_{\max} &= T_{j \max} S_0 = \mathbf{v}_{mi} \Psi_m S_0 / s_{ij}^{\Psi} \end{split}$$

Therefore, for the transverse piezo drive this characteristic is evaluated

$$\Delta h = \Delta h_{\text{max}} \left( 1 - F/F_{\text{max}} \right)$$
  

$$\Delta h_{\text{max}} = d_{31}E_3h$$
  

$$F_{\text{max}} = d_{31}E_3S_0/s_{11}^E$$
  
At  $d_{31} = 2 \cdot 10^{-10} \text{ m/V}, E_3 = 0.75 \cdot 10^5 \text{ V/m}, h = 2.5 \cdot 10^{-2} \text{ m}, S_0 = 1.5 \cdot 10^{-5}$ 

m<sup>2</sup>,  $S_{11}^E$  = 15·10<sup>-12</sup> m<sup>2</sup>/N the values  $\Delta h_{max}$  = 375 nm and  $F_{max}$  = 15 N are found at error 10%

In static the deformation of a nano drive

$$\frac{\Delta l}{l} = \mathbf{v}_{ml} \Psi_m - \frac{S_{ij}^* C_e}{S_0} \Delta l$$
$$F = C_e \Delta l$$

The adjustment characteristic of a nano drive is evaluated

$$\Delta l = \frac{v_{mi} l \Psi_m}{1 + C_e / C_{ij}^{\Psi}}$$

here  $s_{ij} = k_s s_{ij}^E$  the elastic compliance,  $k_s$  - the coefficient of the change or elastic compliance

$$\left(1-k_{mi}^2\right) \le k_s \le 1$$

The expression for Figure 3 is evaluated

$$W(s) = \Xi_2(s)/U(s) = k_r/N(s)$$

$$N(s) = a_0 s^3 + a_1 s^2 + a_2 s + a_3$$

$$a_0 = RC_0M_2$$
,  $a_1 = M_2 + RC_0k_v$ 

$$a_2 = k_v + RC_0C_{ij} + RC_0C_e + Rk_rk_d$$
,  $a_3 = C_e + C_{ij}$ 

here  $k_{v}$  is the speed damping coefficient.



Figure 3: Scheme of Piezo Drive at One Fixed Face

At R = 0 the expression is evaluated

$$W(s) = \frac{\Xi(s)}{U(s)} = \frac{k_{31}^U}{T_t^2 s^2 + 2T_t \xi_t s + 1}$$
$$k_{31}^U = d_{31} (h/\delta) / (1 + C_l / C_{11}^E)$$
$$T_t = \sqrt{M / (C_l + C_{11}^E)}, \ \omega_t = 1/T_t$$

For M = 3 kg,  $C_t = 0.1 \cdot 10^7$  N/m,  $C_{11}^E = 1.8 \cdot 10^7$  N/m the values  $T_t = 0.4 \cdot 10^{-3}$  s,  $\omega_t = 2.5 \cdot 10^3$  s<sup>-1</sup> are calculated at error 10%.

The static deformation

$$\Delta h = \frac{d_{31}(h/\delta)U}{1 + C_1/C_{11}^E} = k_{31}^U U$$

For  $d_{31} = 2.10^{-10} \text{ m/V}$ ,  $h/\delta = 30$ ,  $C_I/C_{11}^E = 0.2$ 

the coefficient  $k_{31}^U$  = 5 nm/V is determined at error 10%.

#### Conclusion

For a nano drive the structural model is evaluated. The matrix of the deformations is constructed. The characteristics of the piezo drive are determined for biomedical research.

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